

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Group Art Unit: 2861
Examiner: Hai Chi Pham
Confirmation No.: 6100

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In re PATENT of:

Inventor(s): Mitsuhiro OGIHARA et al.

Appl. No.: 10/705,895

Filed: November 13, 2003

Patent No. 7,239,337 B2

Issue date: July 3, 2007

For: COMBINED SEMICONDUCTOR APPARATUS
WITH THIN SEMICONDUCTOR FILMS

Atty. ref.: MAE 300

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Examiner Pham:

This is a Citation of Prior Art under 37 CFR 1.501.

The owner of the above-identified patent hereby submits copies of two Chinese patent documents and one European patent document, which were first cited in the attached Chinese Office Action, issued in connection with the corresponding Chinese patent application No. 200310118175.4. Also attached are English-language abstracts of the Chinese patent documents and an English-language translation of the Chinese Office Action, from which any relevance of the documents can be gleaned. The documents are listed on the attached form 1449. Also listed on the attached form PTO-1449 are two U.S. patents, which were also cited in the Chinese Office Action. Any relevance of these U.S. patents is self-evident.

It is brought to the Examiner's attention that the Japanese patent document number 10-063807, which was also cited in the aforementioned Chinese Office Action, is not being submitted with this Citation of Prior Art, since it was previously submitted with the IDS filed on November 13, 2003, with the filing of the above-identified application.

Respectfully submitted,

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August 10, 2007

Date

RHB/vm



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FORM PTO-1449 CITATION OF PRIOR ART		Atty. reference:	Application No.:	Patent No.:			
		MAE 300	10/705,895	7,239,337 B2			
		Applicant(s): Mitsuhiko OGIHARA et al.		Date of Patent: July 3, 2007			
		Filing date: November 13, 2003	Group art unit: 2861	Conf. No.: 6100			
US PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA	US-4,936,808	06/26/1990	Lee			
	AB	US-5,793,405	08/11/1998	Shakuda			
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation
	AC	EP 1 104 937 A1	06/06/2001	EUROPE			N/A
	AD	CN 1159786A	09/17/1997	CHINA			Abstract
	AE	CN 1216833A	05/19/1999	CHINA			Abstract
Examiner:					Date considered:		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							